

X-band manufacturing at CERN



Band
Prototypes
Production

On behalf of the team
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EN/MME/MA



Summary



- Production status
- Structures
 - T24 G Open (Halves)
 - TD24 R05 SiC
 - Rectangular disc
 - T24R05
 - TD26R1CC
 - TD31
 - Klystron base
 - TD26 Halves
- Components
 - Open Hardware
 - Under development

Status

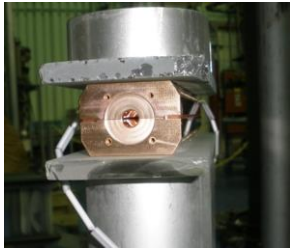




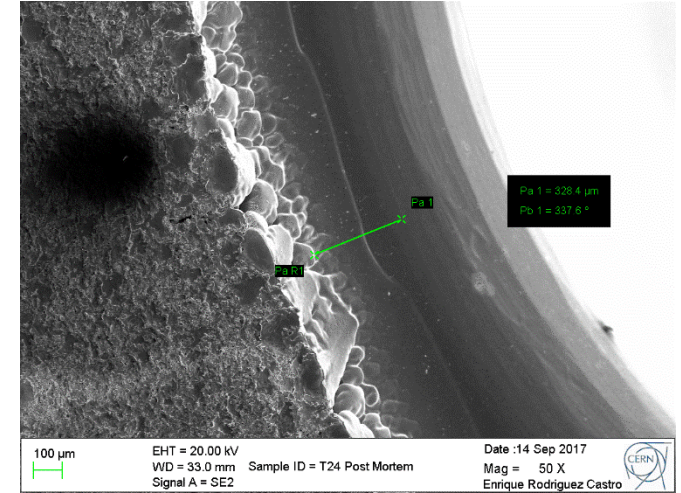
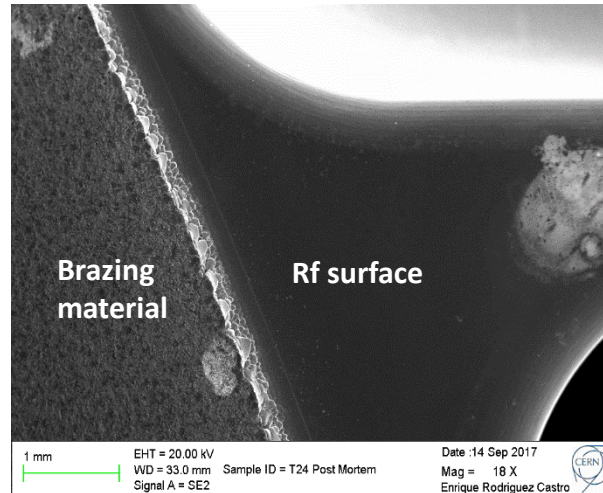
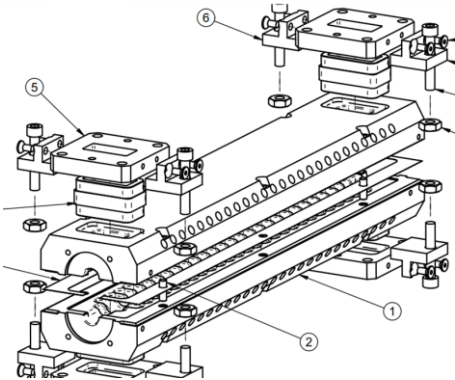
Structures

T24 G Open (Halves)

- KLY T24-CLIC-G-Open fabricated by SLAC. High power tested at CERN
- Conditioning: 200ns pulse length for 100 MV/m with BDR of 10^{-6} bbp
- Gold-copper (25-75) brazing shim.

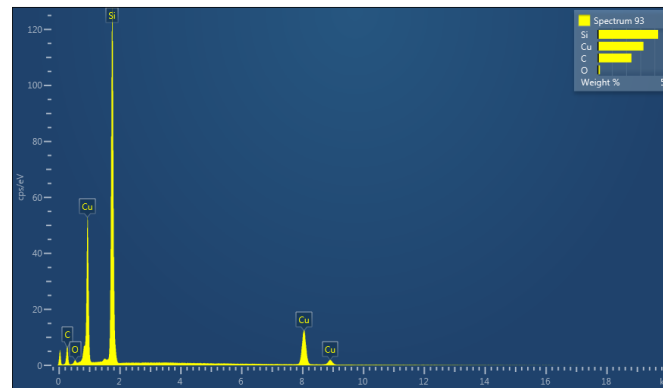


Andy Haase 2015

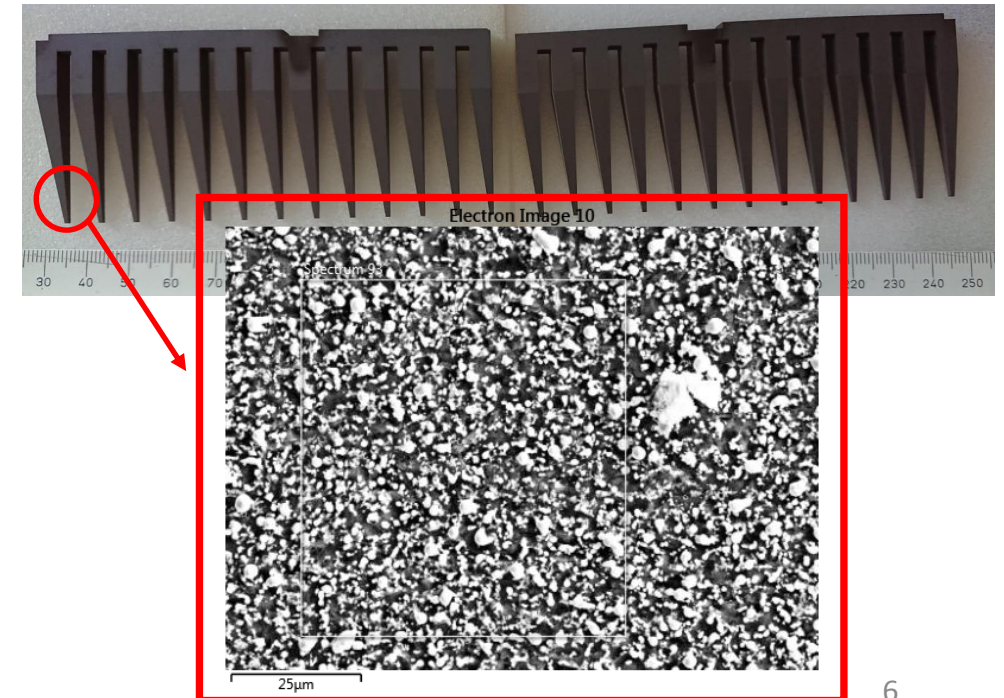


TD24 R05 SiC N1

- The gradient of structure was close to 100 MV/m
- Hot cell around 3rd
- SiC damps **copper coated**
 - During heating cycles? 4 heating cycles with SiC combs out of 10 total cycles
 - During high power test? Sputtering due to breakdowns? More Cu on the tip and near the hot cell

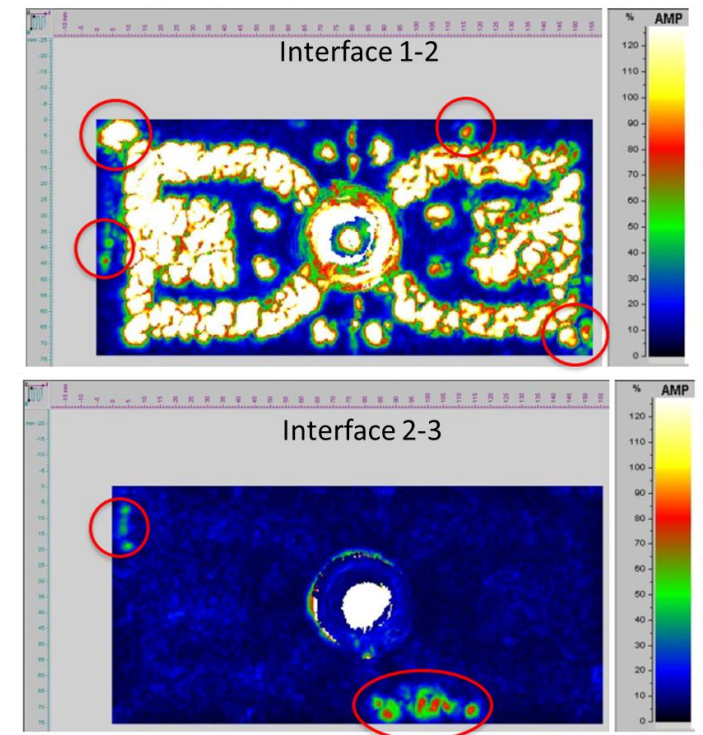
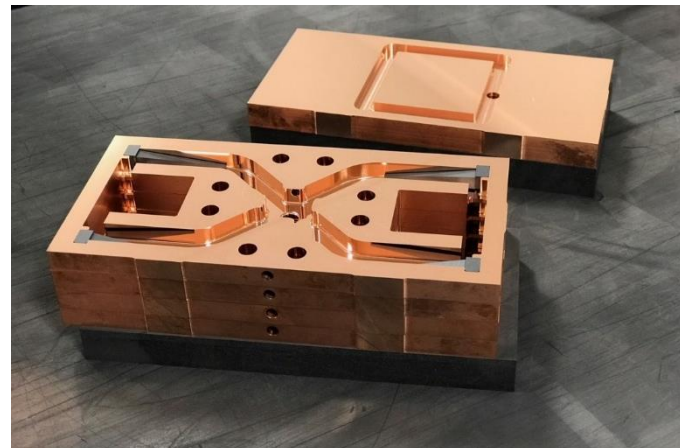
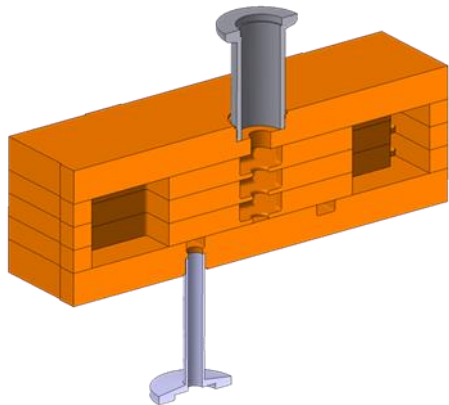


Element	Line Type	Wt%	Wt% Sigma
C	K series	23.72	0.32
O	K series	1.49	0.09
Si	K series	42.58	0.21
Cu	K series	32.22	0.20
Total:		100.00	



CLIC G bent WG prototype cell

- Rectangular cell
- Prototype for bonding test
 - Bonding successful at 95%. Unfortunately, it leaks.
 - SiC absorbers difficult to be placed. Wrong dimensions



T24R05

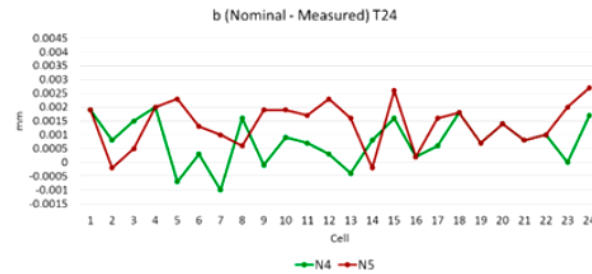
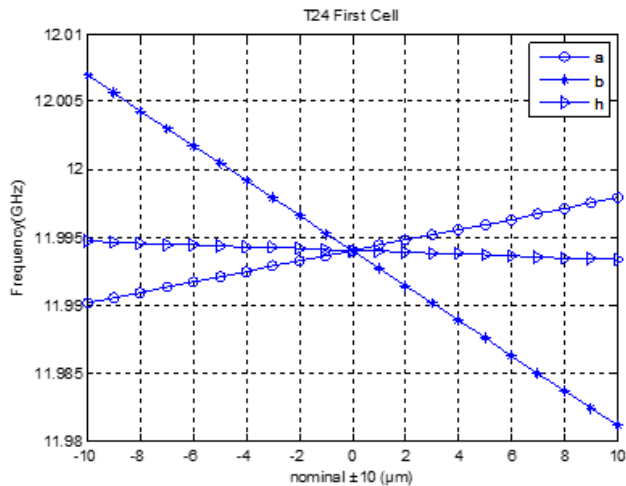


X-band Production at CERN					
	RF Design	Mechanical design	Manufacturing	Assembly	High Power
T24					

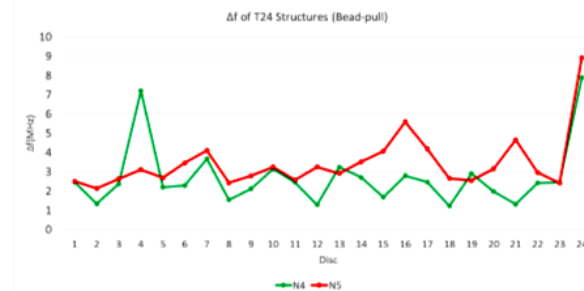
- 24 undamped cells
- Weak tapering of the irises
- \varnothing 45 mm
- Interlock design

T24R05

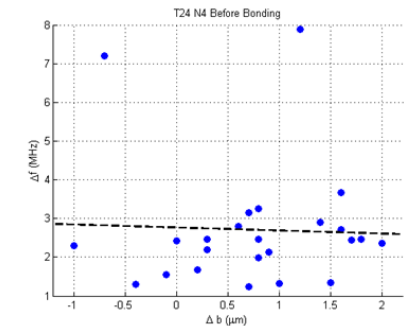
- To assess the changes on the geometry of the cells before and after bonding
 - Sensitivity analysis of most important parameters
 - Correlation of RF measurements (bead pull measurement) vs mechanical measurements (CMM and optical measurements): **b parameter**




b parameter was always smaller than nominal
Data range: N4– 4 µm, N5–3 µm



Frequency deviation are uniform with reduced variability

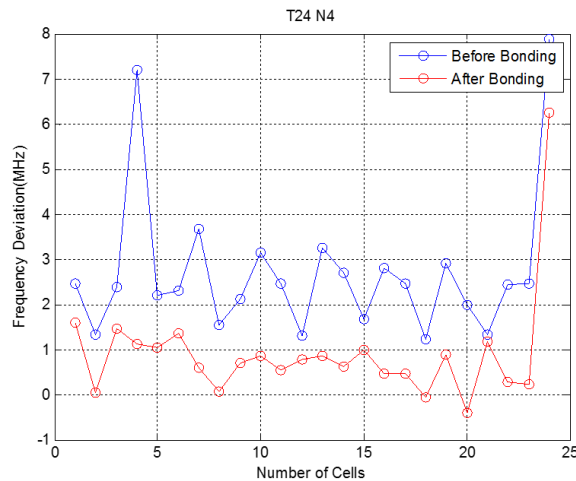


 $r = -0.038$
No correlation

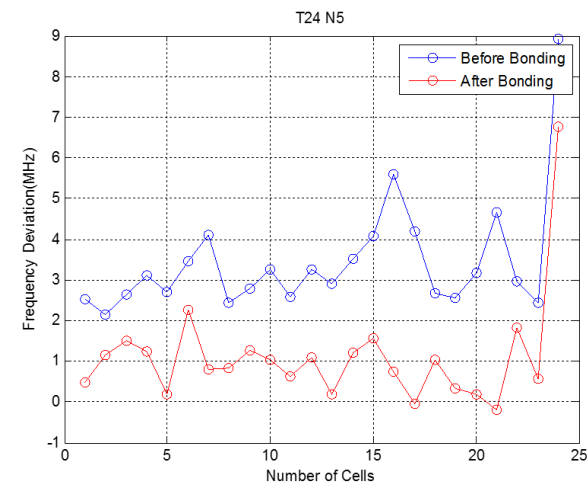
- Another type of correlation different than linear? Combined effect of more than one factor?

T24R05

- Frequency deviation before and after bonding
- Reduction of frequency may indicate a change on the geometry
 - The results are in the range of the accuracy (lack of RF contact) of the bead-pull measurements: are we measuring noise?
 - However, disc diameter reduction has been observed in several structures



Diameter after bonding: Not measured
Straightness: 15 μm



Average diameter reduction (after bonding): 7 μm
Straightness: 30 μm

TD26R1CC

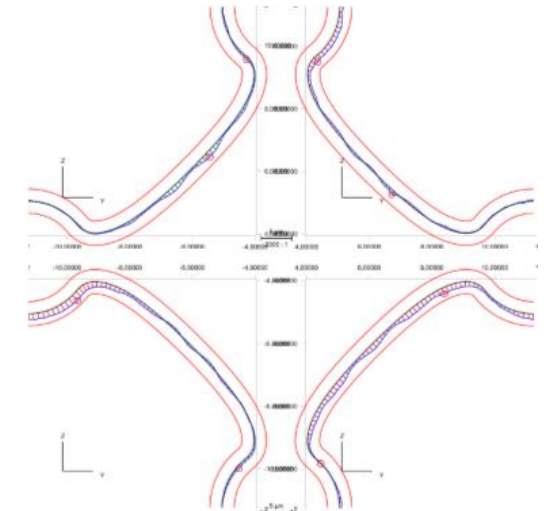
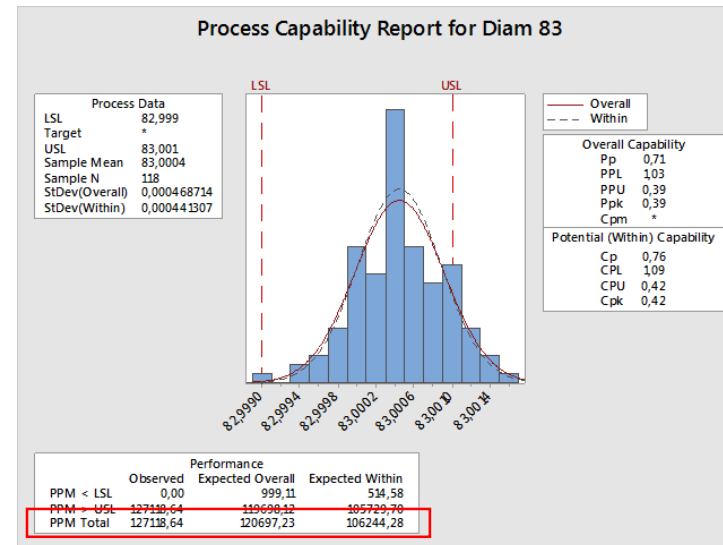
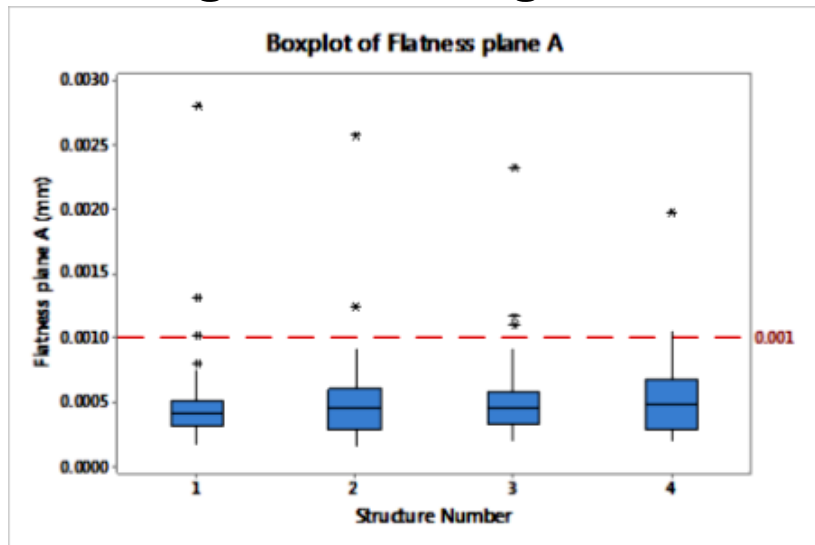


X-band Production at CERN				
	RF Design	Mechanical design	Manufacturing	Assembly
TD26				

- 26 tapered cells with integrated coupling cells.
- Design changes:
 - “Nose” of the waveguide from an elliptical geometry to a **4-th order polynomial function**. RF Improvement
 - The **radius** at the bottom of the RF waveguide was **increased from 0.5 mm to 1 mm** to allow the use of bigger milling cutter. Economic
 - Disc **diameter was increased from 74 mm to 83 mm**. Design

TD26R1CC

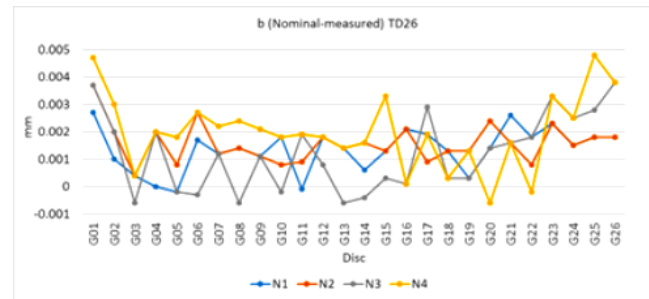
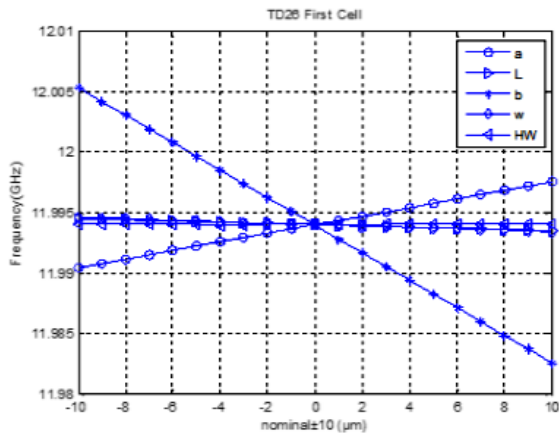
- The total fabrication included four structures: 118 discs: the biggest amount of discs ever produced in a single order
- The parts were produced by a combination of Ultra-Precision diamond fly cutting, milling and turning



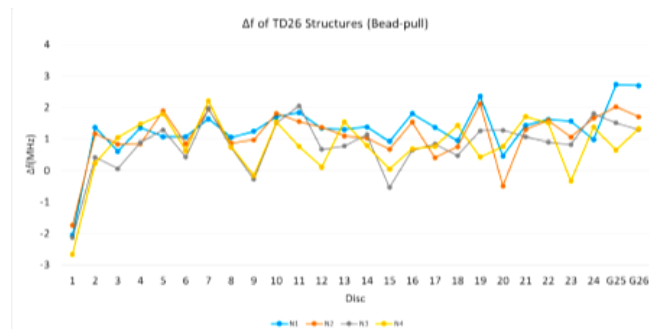
At the beginning of the fabrication the tolerance (disc diameter and flatness) was relaxed from $\pm 1 \mu\text{m}$ to $\pm 2 \mu\text{m}$. The process reaches a $Cpk = 1.1$ thus 14 PPM

TD26R1CC

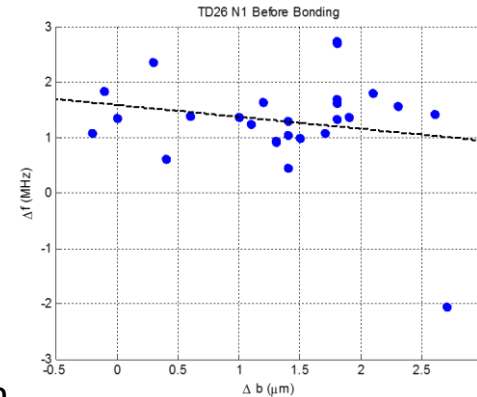
- Same procedure for T24: Sensitivity analysis (b and a), mechanical/optical measurements and frequency deviation before bonding
- No correlation in N1-N3 structures. Medium correlation in N2-N4



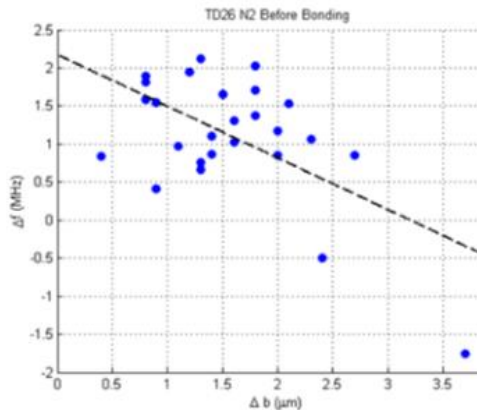
b parameter was always smaller than nominal
 Data range: N1- 2 µm, N2-3 µm, N3-4 µm, N4-5 µm



Frequency deviation are uniform with reduced variability



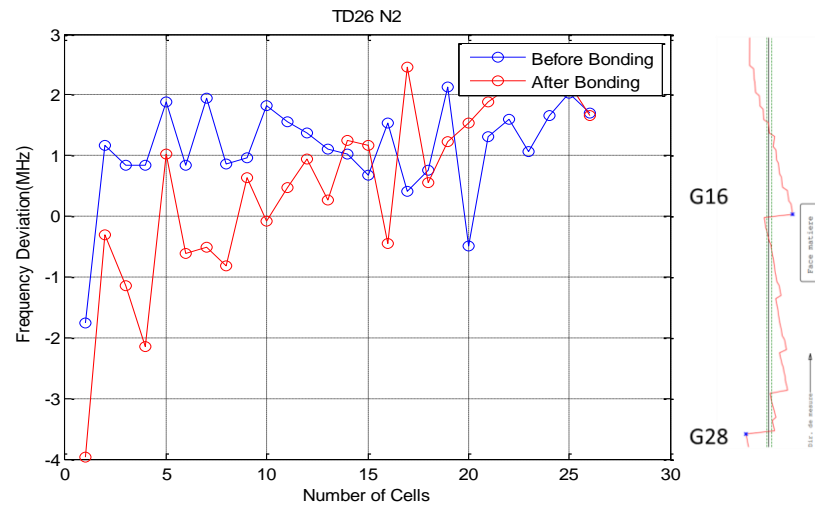
$r = -0.193$



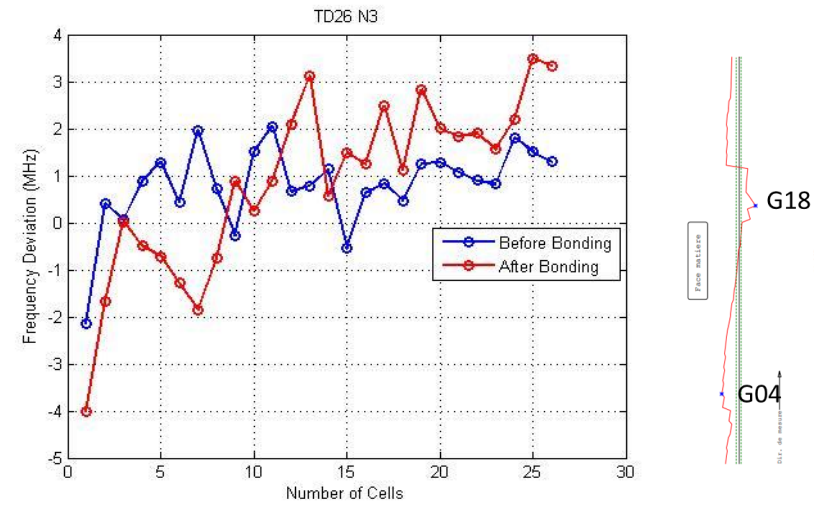
$r = -0.59$

TD26R1CC

- Frequency deviation before and after bonding
- Measurements affected by bonding stack straightness
 - Frequency deviation reduction not homogeneous
 - Difficult to tune (after bonding and brazing) structures N2 and N3



Average diameter reduction (after bonding): 13 μm
 Average straightness: 70 μm

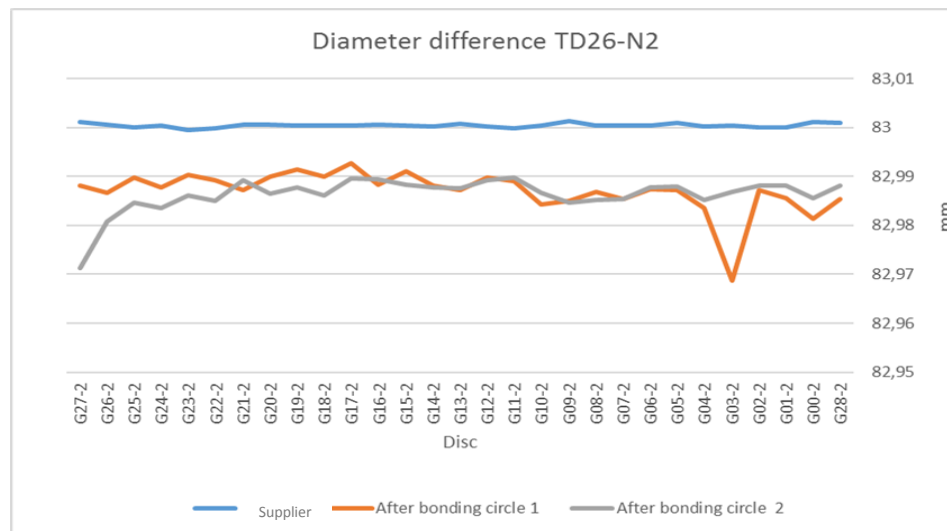


Average diameter reduction (after bonding): 12 μm
 Average straightness: 50 μm

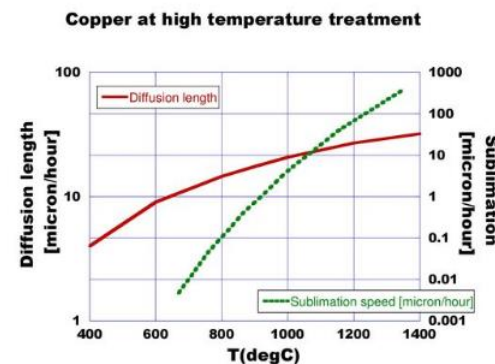
TD26R1CC

- Identical bonding cycles on different days for N1, N2 and N3: 1040 °C – 1.5 hours
- Observations:
 - There is a disc diameter reduction in the three structures: average 12 μm
 - There is a difference of diameter between two circles measured on the same disc: average 3 μm
 - There is a difference on height on measured after bonding N1: 25 μm
- Structure N1 will be thoroughly measured to have information about internal geometry changes.

Higo, 2016



Compromised parameters for large hydrogen diffusion and less copper sublimation

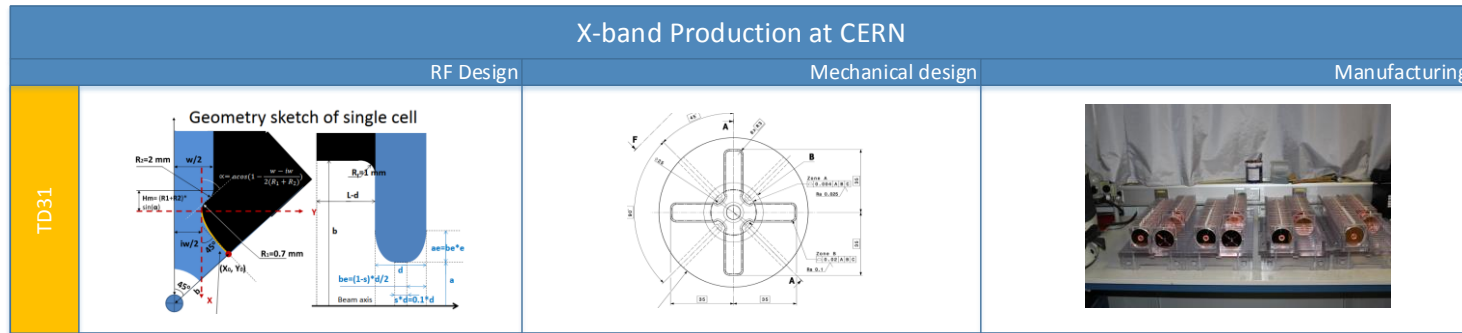


- Temperature not so sensitive to diffusion
- High temperature gives more sublimation, more sensitive to temperature (900C, 1 hour → 1 micron)

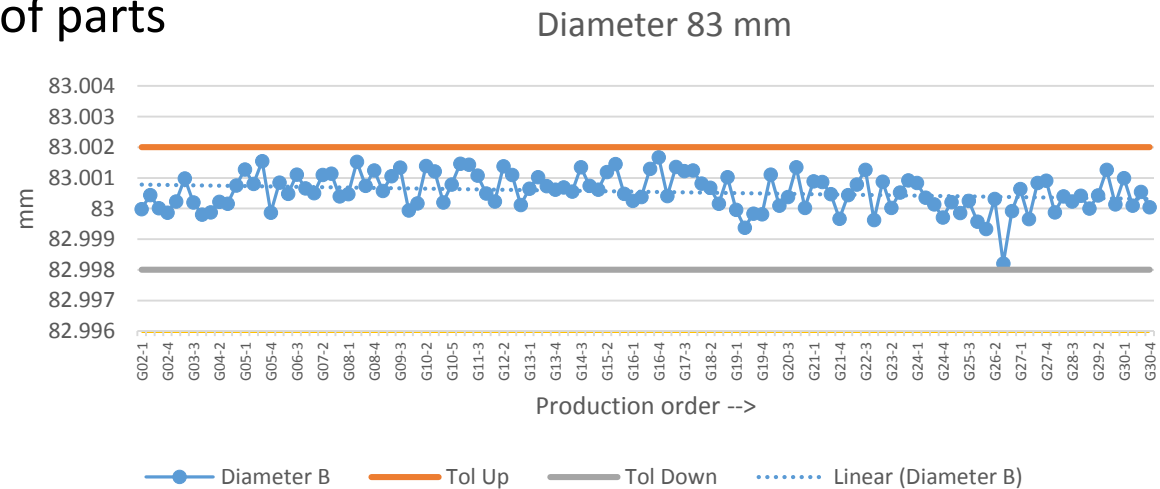
- Need to find some parameters
- A bit lower temperature but longer period

Compromise with cost:
750C, 1 day

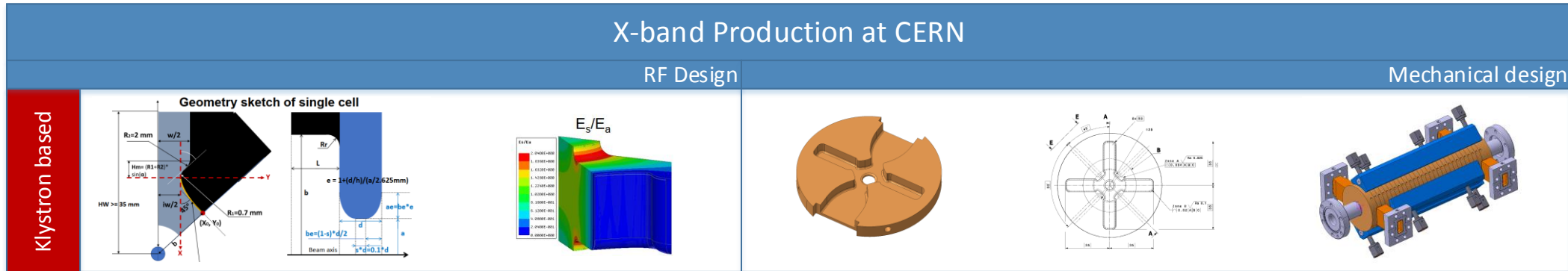
TD31R1CC



- Similar geometry of TD26 (Ø83 mm)
- Production of 138 cells + components
- Confirmed the Cpk with $\pm 2 \mu\text{m}$ Tolerance: **0 defectives parts**
- Improvements on transport and handling of parts



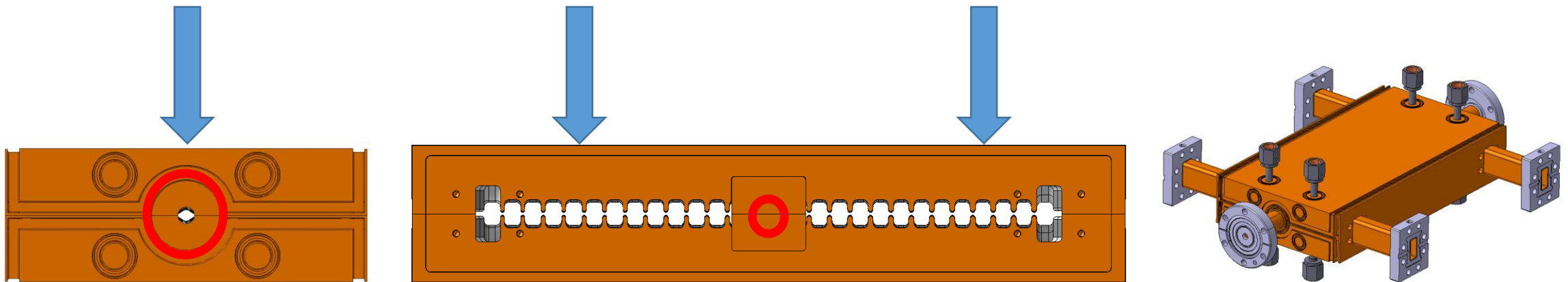
Klystron based



- Alternative scenario for 380 GeV
- 75 MV/m accelerating gradient
- It can be easily tested and implemented faster than two-beam modules
- Competitive cost at lower energy
- From the manufacturing point of view similar to TD26 and TD31
 - Smaller irises
 - Smaller height
 - Similar tolerances

TD26 Halves

- New Electron Beam Welding
- Heat treatments are avoided
- There are less components
- Alignment is critical: deformation of rings, due to Herzian contact forces, by a load applied to the halves. Collaboration with Dutch company to define the alignment features

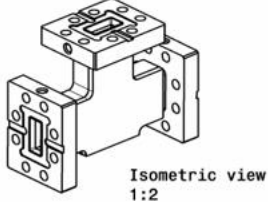
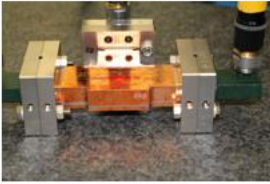
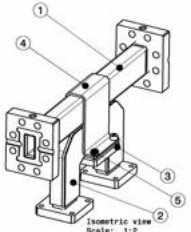

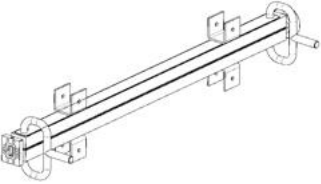

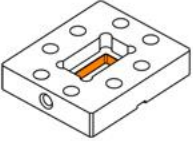



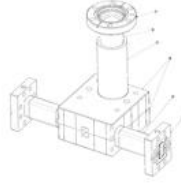
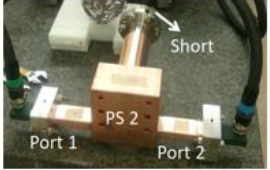
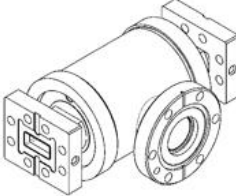
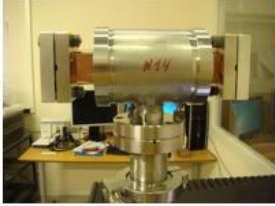
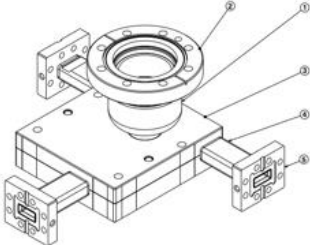
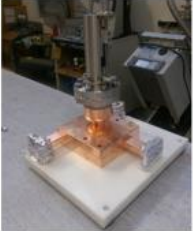
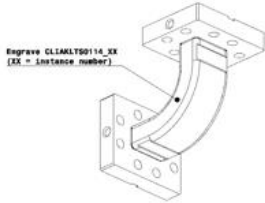



Components

Open Hardware catalogue



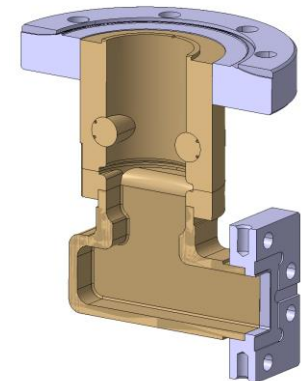
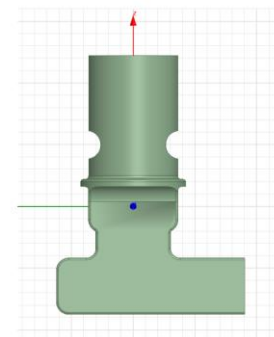
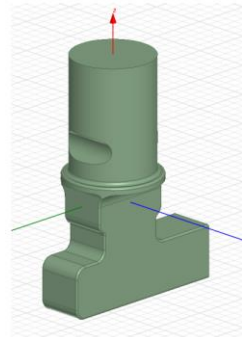
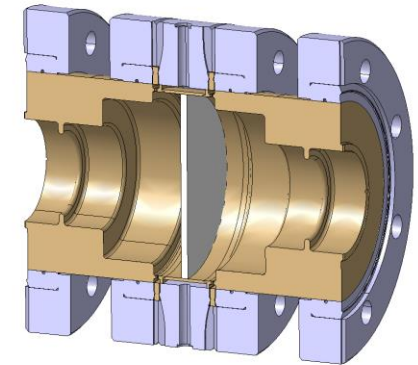
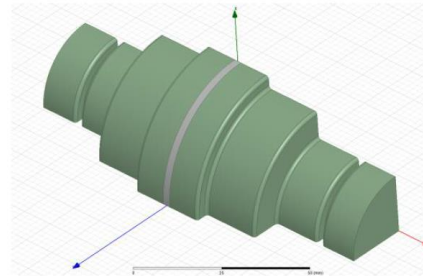
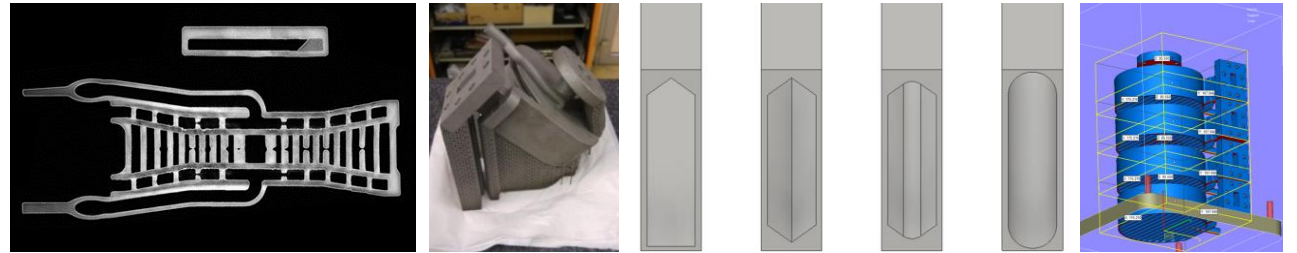
Component	Design	Photo
3db Splitter	 <p>Isometric view 1:2</p>	
Directional Coupler 60 dB	 <p>Isometric view Scale: 1:2</p>	
High Power loads		
IUWR90 flanges	 <p>Isometric view 1:1</p>	

Component	Design	Photo
Phase Shifter		
Pumping port	 <p>Isometric view Scale: 1:1</p>	
RF Switch		
Waveguides	 <p>Engrave CLIAKTS0114_XX [XX = Instance number]</p>	



Components under development

- Spiral load
 - Optimization for 3D printing
- Travelling Wave X-band RF Window
 - Peak Power 75MW
- Double height WR90 mode converter
 - TE_{10} (rectangular waveguide) to TE_{01} (circular waveguide)



Conclusions

- Next structures for tendering:
 - Klystron based structure (production)
 - Halves (production)
 - TD31 (assembly)
 - Repeat bonding test of rectangular disc with similar parts
- Components
 - RF window and mode converter fabrication and testing (in house)
 - Spiral load (in house)
- Structure's internal geometry changes
 - SiC copper coated (TD24 R05 SiC and rectangular disc)
 - Frequency changes (T24 and TD26)
 - External diameter reduction and height changes (T24 and TD26)
 - TD26R1CC measurement will help us to better understand (started)



Thank you for your attention

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Sergio Gonzalez Anton

Ready for questions

